

Notice of References Cited	Application/Control No. 10/566,412		Applicant(s)/Patent Under Reexamination RUHE ET AL.	
	Examiner ROBERT EOM		Art Unit 1797	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,020,830	05-1977	Johnson et al.	600/348
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Burgmair et al., Humidity and temperature compensation in work function gas sensor FETs, 03/27/2003, Elsevier Science B.V., Sensors and Actuators B 93, pp271-275.
	V	Sweryda-Krawiec et al., A new interpretation of serum albumin surface passivation, 02/14/2004, American Chemical Society, Langmuir 2004, 20, pp2054-2056.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.